

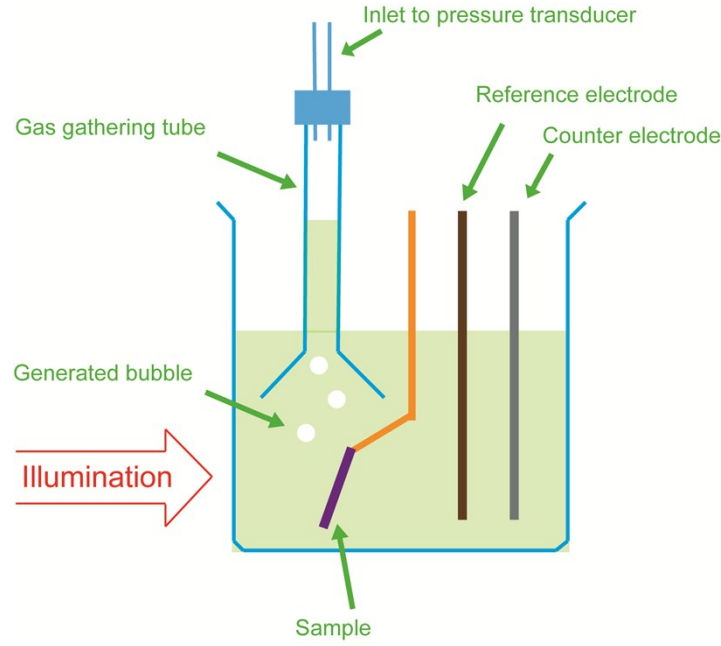
# **Silicon Nanowires Loaded with Iron Phosphide for Effective Solar-Driven Hydrogen Production**

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## **Supporting Information**

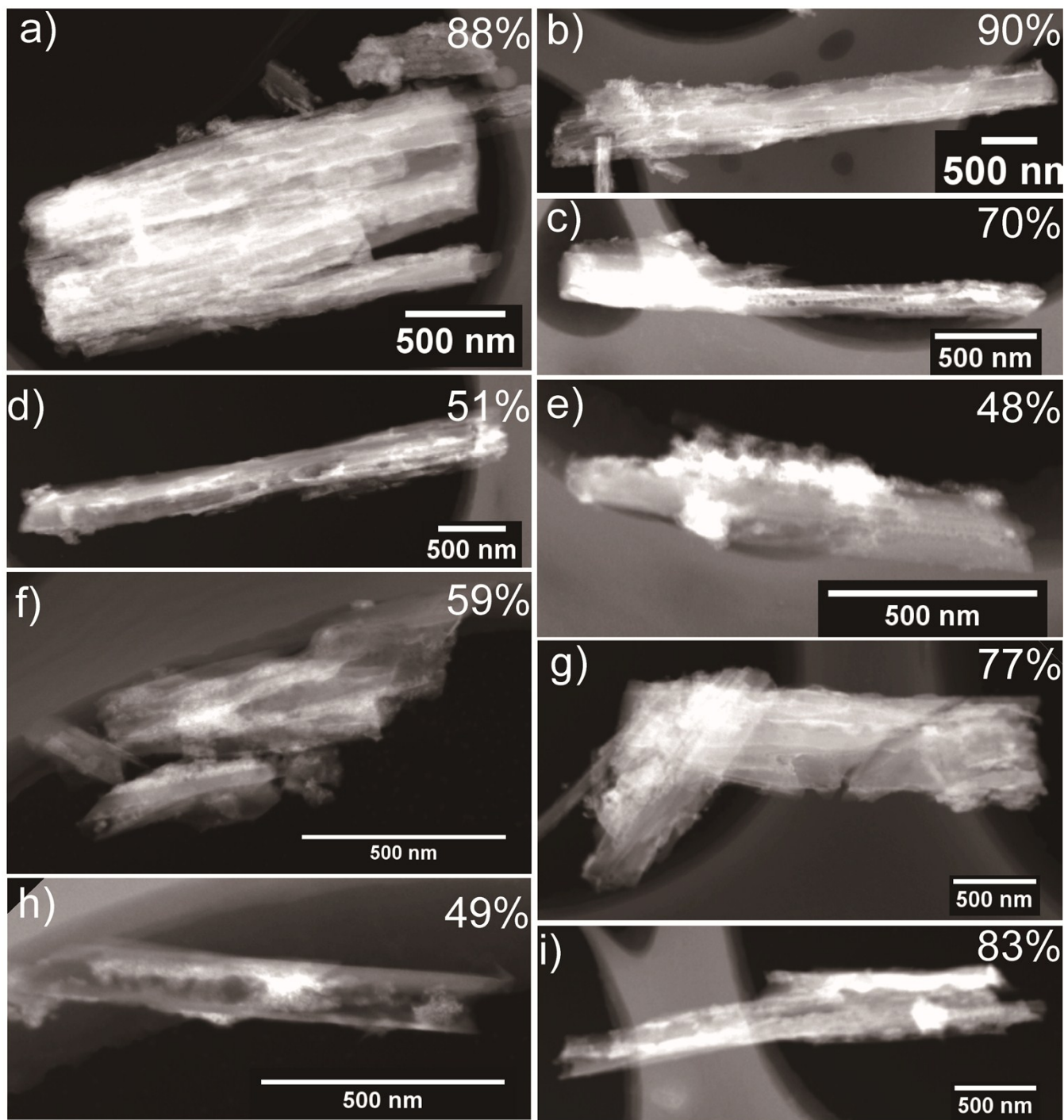


**Figure S1.** Illustration of the setup used to monitor the volume of generated gas.

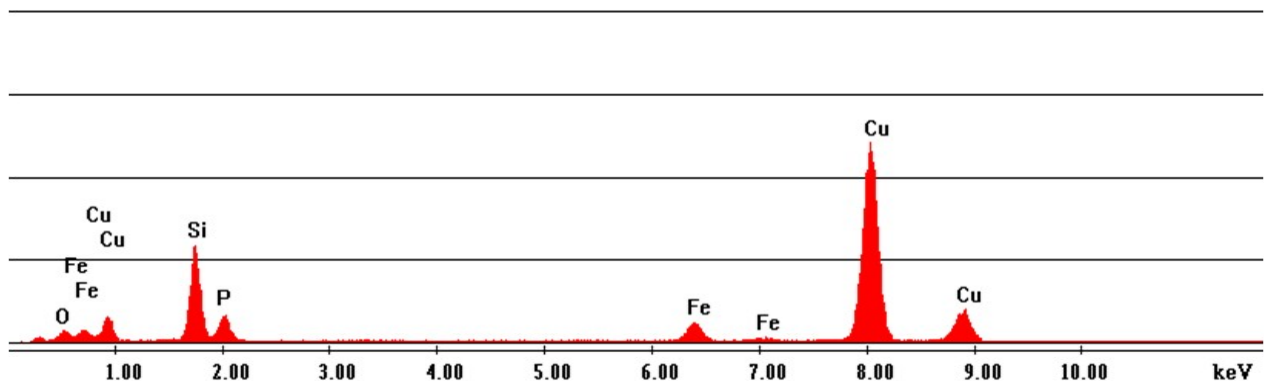
If the initial height of water in the gas gathering tube before the gas gathering experiment is  $h_0$ , and after the  $i-t$  experiment the generated gas is gathered into the tube and the final height of water in the gas gathering tube become  $h_1$ , then the volume of generated gas ( $V$ ) should be  $s(h_0-h_1)$ , where  $s$  is the inner cross-sectional area of the gas gathering tube.

At the initial status, the pressure inside the gas gathering tube ( $P_0$ ) is  $P - \rho gh_0$ , where  $P$  is the atmospheric pressure,  $\rho$  is the density of water, and  $g$  is the acceleration due to gravity. The output voltage of the differential pressure transducer would be  $U_0 = k(P - P_0) = k\rho gh_0$ , where  $k$  is the sensitivity of the differential pressure transducer (1 mV/Pa for a Freescale MPXV7002DP). When the height of water in the gas gathering tube decreases to  $h_1$ , the pressure inside the gas gathering tube becomes  $P_1$ , and  $P_1 = P - \rho gh_1$ . Then, the output of the differential pressure transducer is  $U_1 = k(P - P_1) = k\rho gh_1$ .

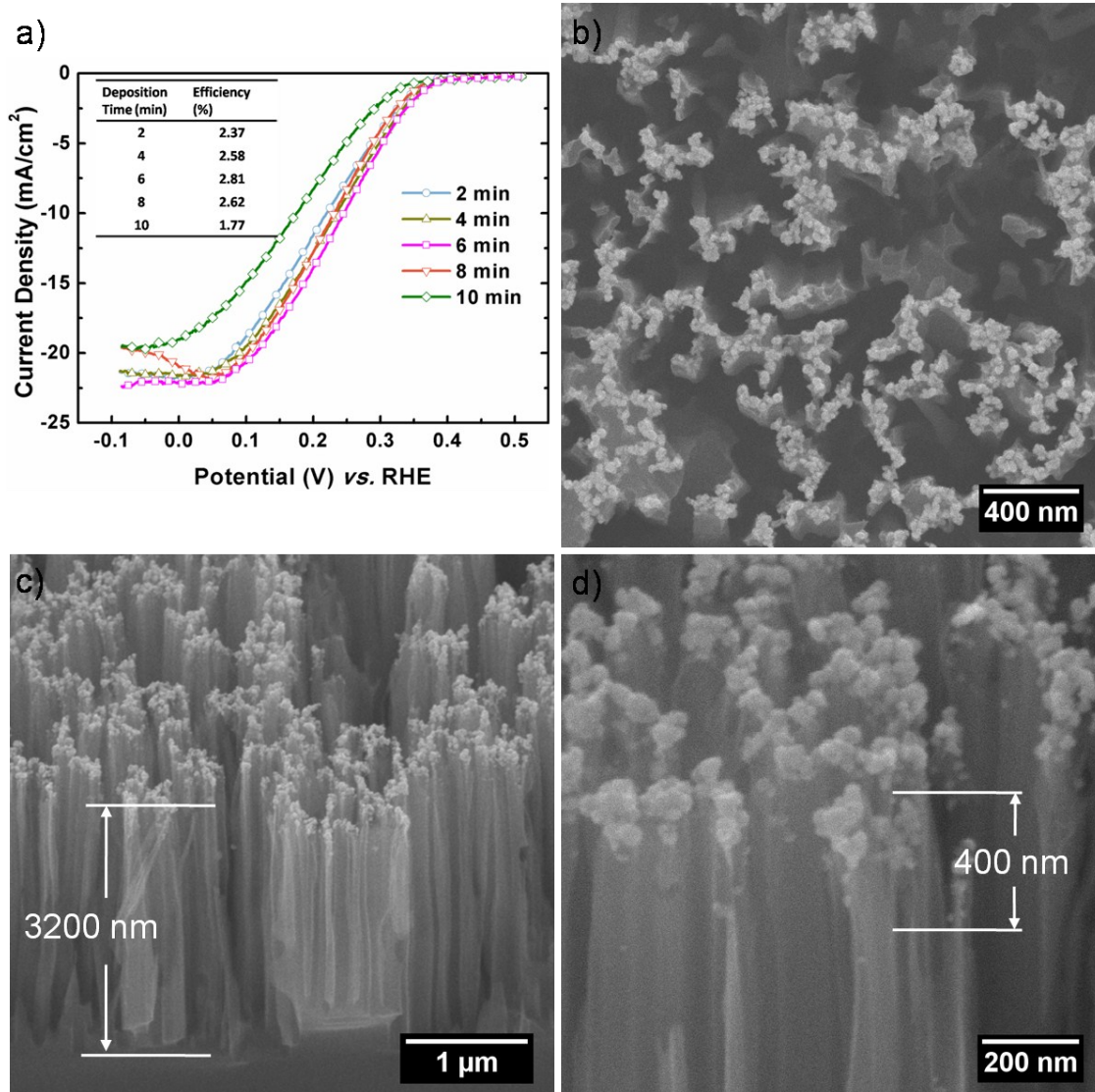
Accordingly, the volume of generated gas can be computed by  $V = s(h_0 - h_1) = s(U_0/k\rho g - U_1/k\rho g) = s(U_0 - U_1)/k\rho g = C(U_0 - U_1)$ , where  $C$  is a coefficient that can be calibrated by injecting a known volume of gas into the gas gathering tube and recording the variation of output voltage of the differential pressure transducer.



**Figure S2.** STEM image of the SiNWs/FeP. The value on the upper right corner of each image is the coverage of FeP on the surface of SiNWs estimate by software ImageJ. The coverage is computed by the projected area of FeP (component with brighter contrast in STEM image) divided by the projected area of SiNW.



**Figure S3.** EDX spectrum of SiNWs/FeP recorded in TEM. The signal of Cu comes from the copper grid used to support the SiNWs/FeP.



**Figure S4.** (a) Polarization curves of SiNWs subjected to Pt electroless deposition with different times. Inset shows the efficiency corresponding to different deposition times of Pt. (b) Plan-view and (c,d) bird-eye's view SEM image of SiNWs/PtNPs with the optimal performance, which was subjected to 6 min Pt electroless deposition. In bird-eye's view SEM image the sample was 45° tilted.

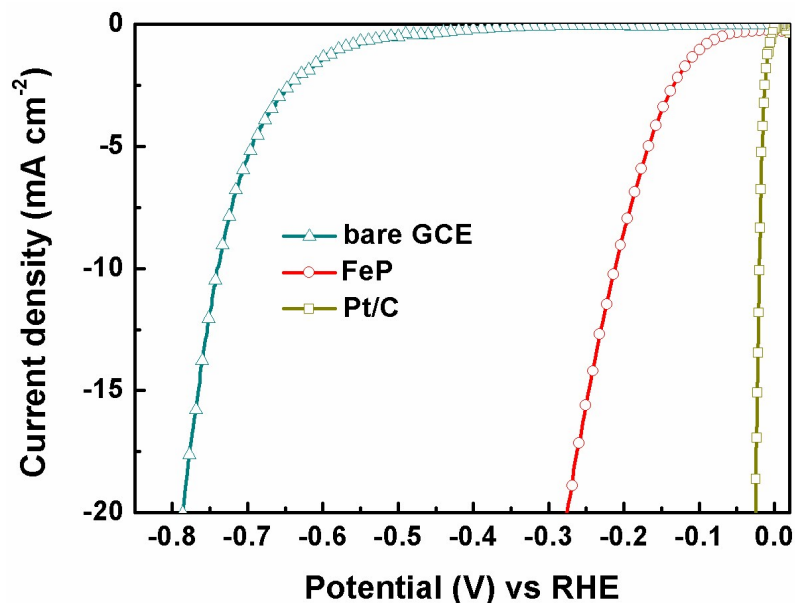
The optimal PCE of SiNWs/PtNPs sample is 2.81% in our experiment (Illumination intensity: 100 mW·cm<sup>-2</sup>). In order to introduce Pt nanoparticles to SiNWs, SiNWs sample was first immersed diluted HF for 5 min to remove surface oxide, and Pt nanoparticles are deposited by immersion of SiNWs into a solution of 0.4 M HF and 1mM K<sub>2</sub>PtCl<sub>6</sub> for different times. Afterwards, the SiNWs samples loaded with Pt nanoparticles were rinsed with copious amount of deionized water and dried in air.

In SiNWs/PtNPs sample, nearly every SiNW was loaded with PtNPs (Figure S4b). For SiNWs with typical length of 3200 nm, PtNPs were found only on the top region of SiNWs, and the length of this region was smaller than 400 nm (Figure S4c and Figure S4d). It is therefore reasonable to estimate that the coverage of Pt on SiNWs was less than 12.5%.

**Table S1.** Key performance of reported results and the corresponding measurement conditions.

| Ref | photocathode  | catalyst                               | $J_{sc}$<br>(mA/cm <sup>2</sup> ) | $V_{oc}$<br>(V) | PCE<br>(%) | Illumination<br>intensity<br>(mW/cm <sup>2</sup> ) | Light source  |
|-----|---|--|-----------------------------------|-----------------|------------|--|---|
| 1   | planar Si, p-n <sup>+</sup> junction                        | Pt                                     | 18.80                             | 0.49            | 5.5        | 38.6   | simulated AM 1.5 spectrum, $\lambda > 635$ nm                 |
|     | planar Si, p-n <sup>+</sup> junction/Ti                     |  | 17.85                             | 0.51            | 6.16       |  |   |
|     | planar Si, p-n <sup>+</sup> junction/Ti/TiO <sub>2</sub>    |  | 21.68                             | 0.51            | 7.77       |  |   |
| 2   | planar Si, p-n <sup>+</sup> junction/Ti                     | MoS <sub>x</sub>                       | 16.4                              | 0.368           | 7.46       | 38.6   | simulated AM 1.5 spectrum, $\lambda > 635$ nm                 |
|     |   | Pt                                     | 14.87                             | 0.48            | 11.66      |  |   |
| 3   | Si microwires, core-shell p-n <sup>+</sup> junction         | Ni-Mo                                  | 9.1                               | 0.46            | 2.21       | 100  | ELH-type W-halogen lamp, AM 1.5G filter                       |
| 4   | Si microwires, core-shell p-n <sup>+</sup> junction         | Pt                                     | 15                                | 0.54            | 5.8        | 100  | ELH-type W-halogen lamp                                       |
|     | Si microwires   |  | 7.3                               | 0.16            | 0.21       |  |   |
|     | planar Si, p-n <sup>+</sup> junction                        |  | 28                                | 0.56            | 9.6        |  |   |
|     | planar Si   |  | 23                                | 0.30            | 2.1        |  |   |
| 5   | Si nanowires  | Ni <sub>12</sub> P <sub>5</sub>        | 21.0                              | 0.40            | 2.97       | 100  | Xe lamp   |
| 6   | Si nanowires  | MoS <sub>3</sub>                       | 24.9                              | 0.36            | 2.28       | 100  | ELH-type W-halogen lamp                                       |
| 7   | Si nanowires  | WS <sub>3</sub>                        | 19.0                              | 0.40            | 2.02       | 100  | Xe lamp   |
| 8   | planar Si/Au film   | Pt                                     | 16.7                              | 0.274           | 0.753      | 100  | halogen lamp  |
|     | planar Si   |  | 16.9                              | 0.265           | 0.784      |  |   |
| 9   | Si nanowires  | Pt                                     | 17                                | 0.42            | 2.73       | 100  | halogen lamp  |
|     | planar Si   |  | 27                                | 0.33            | 2.13       |  |   |
| 10  | Si nanowires  | MoS <sub>2</sub>                       | 1                                 | 0.25            | 0.03       | 100  | Xe lamp with 400 nm cut-off filter                            |
| 11  | Si micro-pillar   | Mo <sub>3</sub> S <sub>4</sub> cluster | 9.45                              | 0.14            | 1.236      | 28.3   | Xe-arc lamp simulated AM1.5G radiation, $\lambda > 635$ nm    |
| 12  | Nanoporous black Si   | —                                      | 2.3                               | 0.1             | 0.024      | 100  | simulated AM1.5 illumination                                  |
| 13  | Tapered Si nanohole arrays                                  | —                                      | 7.5                               | 0.15            | 0.13       | 100  | under AM 1.5 G illumination                                   |
| 14  | Nanoporous Si   | —                                      | 30.6                              | 0.26            | 2.63       | 100  | Xe lamp with an AM1.5 filter                                  |
|     |   | Pt                                     | 28.4                              | 0.4             | 3.23       |  |   |
| 15  | 20 $\mu$ m-thin Si nanoholes                                | Pt                                     | 23.1                              | 0.31            | 1.19       | 100  | a solar simulator (Peccel PEC-L11) under AM 1.5G illumination |
| 16  | 350 $\mu$ m thick p <sup>+</sup> pn <sup>-</sup> -Si(front) |  | 24.6                              | 0.52            | 19.18      |  |   |

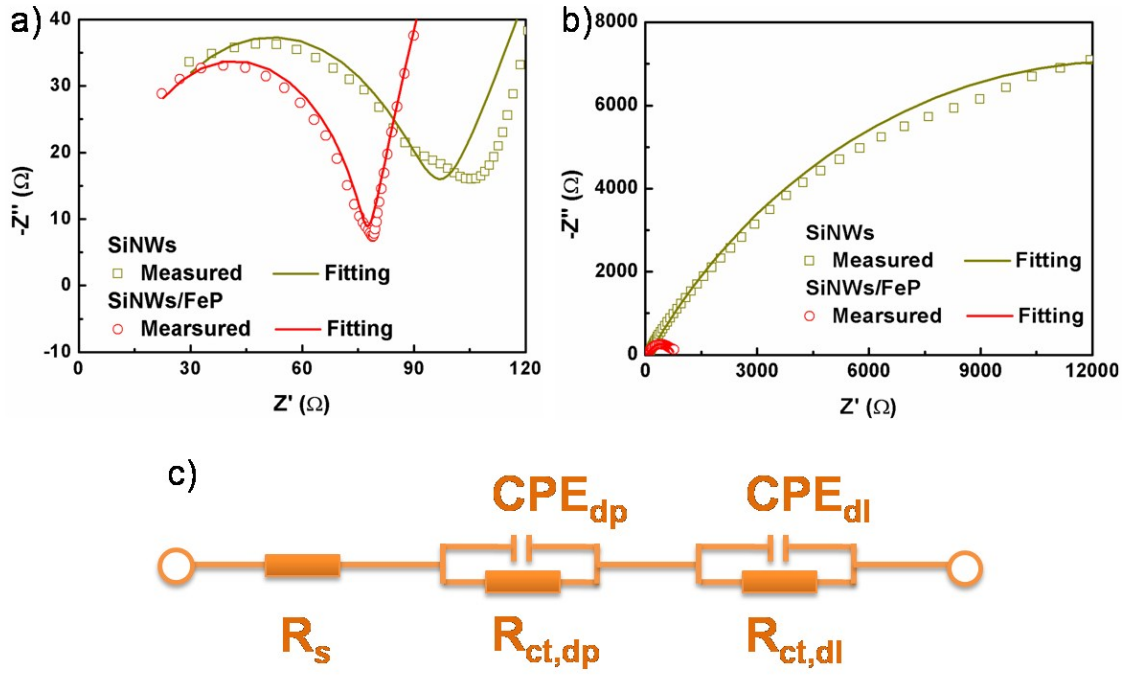
|               |  |    |      |      |      |      |   |
|---------------|--|----|------|------|------|------|---|
|               | 50μm thick p <sup>+</sup> pn <sup>+</sup> -Si(front) | Pt | 23.6 | 0.52 | 19.1 | 41.8 | Xenon lamp with a 635 nm cut-off filter and an AM1.5 filter, λ>635 nm |
|               | 30μm thick p <sup>+</sup> pn <sup>+</sup> -Si(front) |    | 20.3 | 0.5  | 15.7 |      |   |
|               | 350μm thick p <sup>+</sup> pn <sup>+</sup> -Si(back) |    | 6.4  | 0.49 | 5.4  |      |   |
|               | 50μm thick p <sup>+</sup> pn <sup>+</sup> -Si(back)  |    | 16.8 | 0.5  | 13.2 |      |   |
|               | 30μm thick p <sup>+</sup> pn <sup>+</sup> -Si(back)  |    | 16.0 | 0.5  | 12.4 |      |   |
| <sup>17</sup> | Amorphous Si thin film                               | Pt | 11.6 | 0.93 | 5.87 | 100  | a solar simulator (Solar Light, model 16S-300-005) with AM 1.5 filter |



**Figure S5.** The polarization curves of FeP, commercial Pt/C (Johnson Matthey, Hispec 3000, 20 wt.%), and a bare glassy carbon electrode (GCE) in 0.5 M H<sub>2</sub>SO<sub>4</sub> solution. The loading of FeP and Pt/C is 0.285 mg cm<sup>-2</sup>. All potentials are corrected with iR drop.

All measurements were carried out in a three-electrode electrochemical cell. The FeP or Pt/C were loaded onto GCE (3 mm diameter) which was used as a working electrode; a graphite rod (6 mm diameter) was employed as a counter electrode, and a mercury/mercurous sulfate electrode (MSE) was used as a reference electrode. The counter electrode was separated from the working chamber by a porous glass frit. To load catalyst onto the GCE, a dispersion of the catalyst (4 mg) and Nafion solution (5 wt. %, 80  $\mu$ L) in 1 ml of water/ethanol (4/1, v/v) was ultrasonicated using an ultrasonic probe (2 mm diameter, 130 W) for 1 h to form a homogeneous ink, and then 5  $\mu$ L of the ink was dropped onto the polished GCE. The RHE was determined to be -0.694 V *versus* MSE for the 0.5 M H<sub>2</sub>SO<sub>4</sub> solution by the open circuit potential of a clean Pt electrode in the solution of interest purged with H<sub>2</sub> (99.999%). Polarization curves were measured at a sweep rate of 5 mV s<sup>-1</sup>. The current-interrupt method was employed to measure the uncompensated cell resistance (R).





**Figure S6.** (a,b) EIS spectra of the SiNWs and the SiNWs/FeP, (c) A equivalent circuit used for the data fitting of EIS spectra.  $R_s$  represents the overall series resistance of the circuit,  $CPE_{dp}$  is the capacitance phase element for the depletion layer of semiconductor,  $R_{ct,dp}$  is the charge transfer resistance in the depletion layer of semiconductor,  $CPE_{dl}$  is the capacitance phase element for double layer at semiconductor/electrolyte interface, and  $R_{ct,dl}$  is the charge transfer resistance of double layer at semiconductor/electrolyte interface.

**Table S2.** Values of elements in the equivalent circuit (Figure S5) resulted from fitting the EIS data.

| Sample    | $R_s$<br>(Ω) | $Q_{dl}$<br>(F cm <sup>-2</sup> S <sup>n-1</sup> ) | $n_{dl}$ | $R_{ct,dl}$<br>(Ω) | $Q_{dp}$<br>(F cm <sup>-2</sup> S <sup>n-1</sup> ) | $n_{dp}$ | $R_{ct,dp}$<br>(Ω) |
|-----------|--------------|--|----------|--------------------|--|----------|--------------------|
| SiNWs     | 6.004        | 4.26e-5  | 0.6435   | 25540              | 2.732e-8   | 0.8759   | 87.25              |
| error (%) | 138.5        | 3.343  | 1.048    | 3.55               | 93.23  | 8.542    | 11.02              |
| SiNWs/FeP | 5.915        | 1.153e-5   | 0.8226   | 689.1              | 9.289e-9   | 0.9611   | 70.78              |
| error (%) | 29.69        | 4.713  | 0.7848   | 1.176              | 26.55  | 2.159    | 2.91               |

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